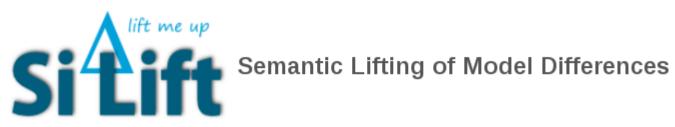
SiLift: Extending EMF Compare with an **Operational View on Model Differences**

Timo Kehrer Software Engineering Group University of Siegen

> Eclipse DemoCamp Stuttgart, 17.07.2013



Outline

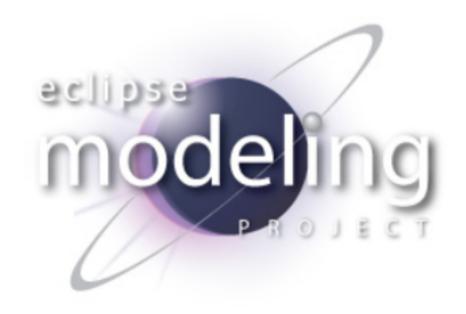
Introduction

The SiLift Approach

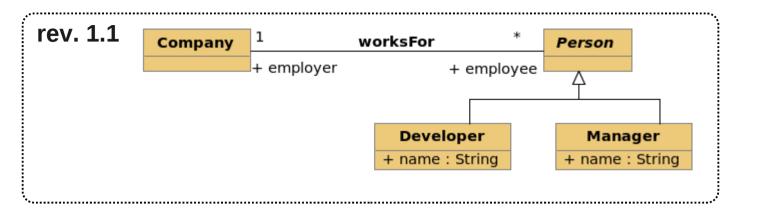
End-user Tool Environment

Summary

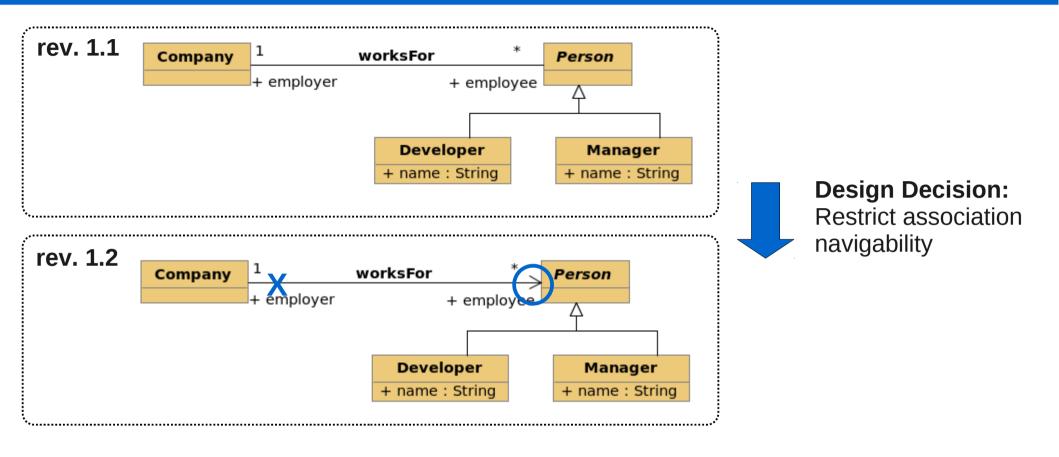
Context: Model-driven Development



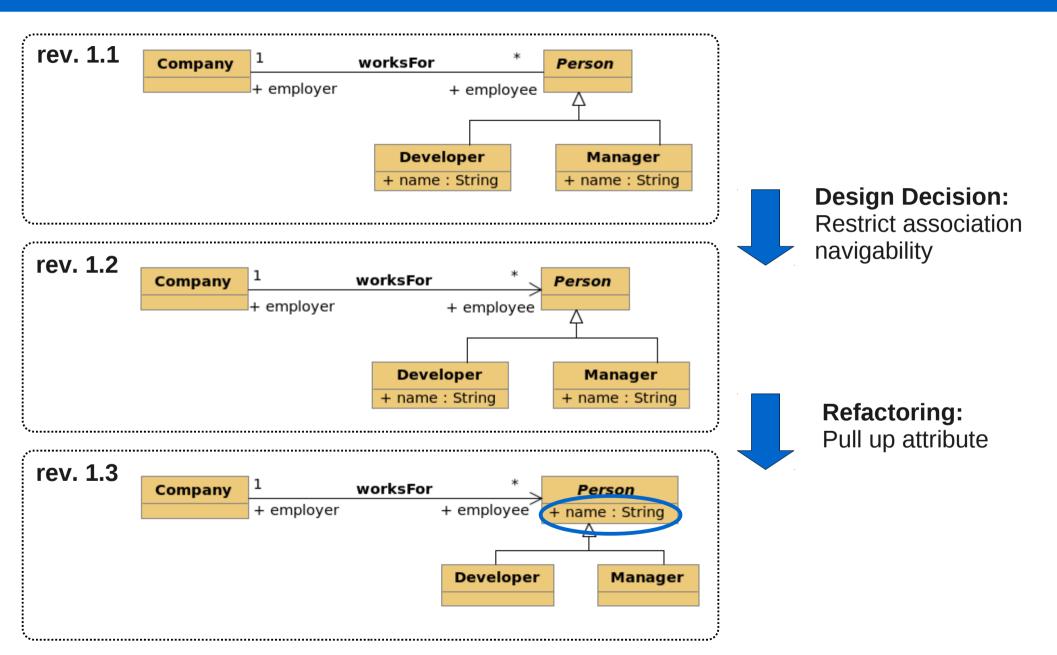
Model evolution



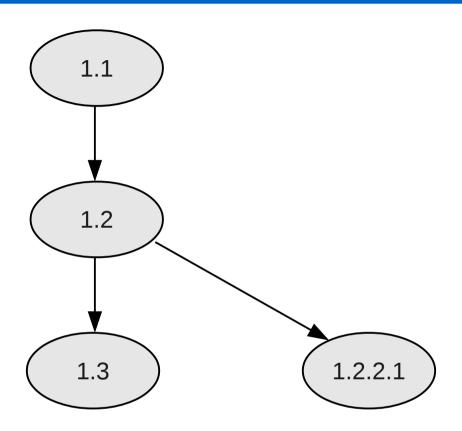
Model evolution



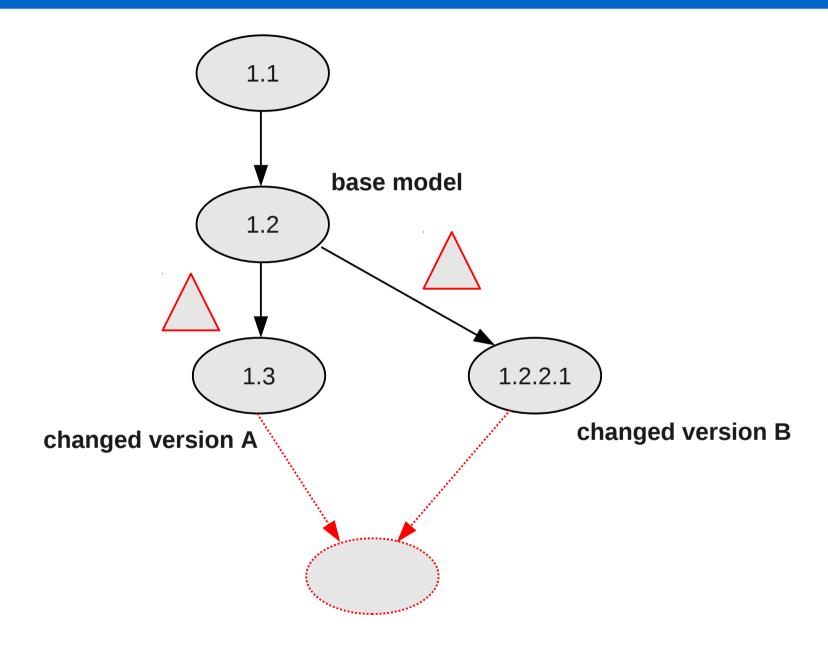
Model evolution



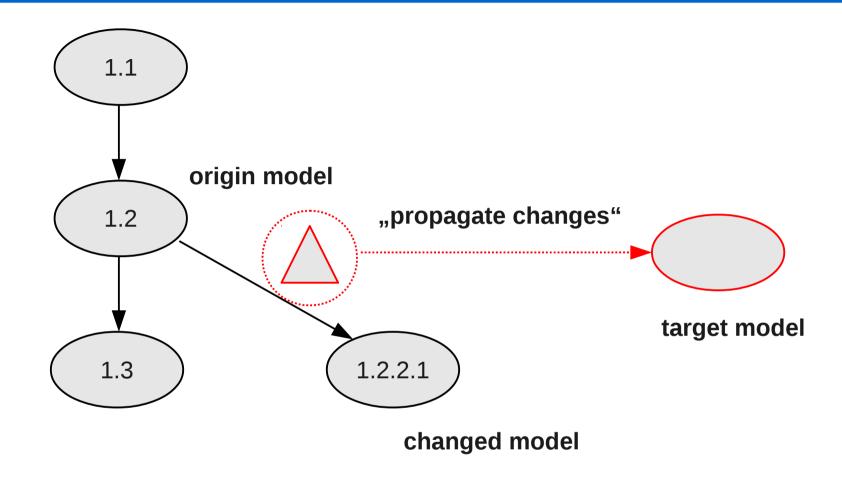
Model versions and variants



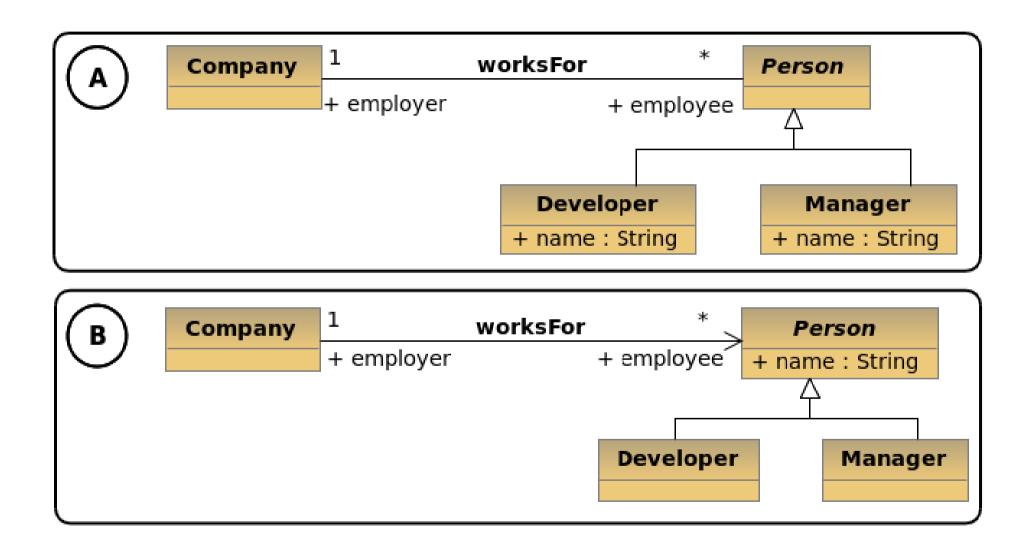
3-Way model merging



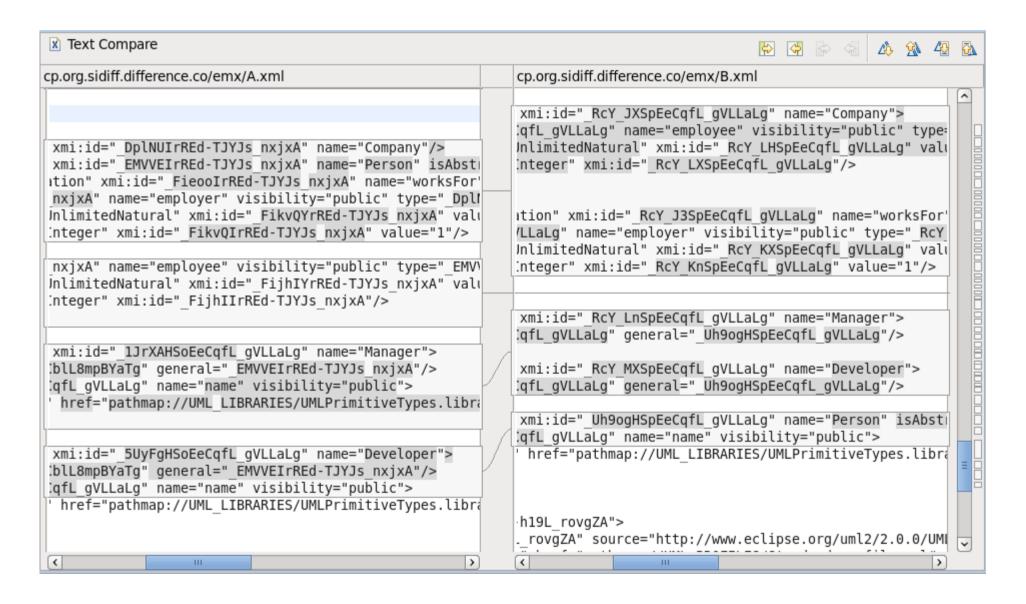
Model patching



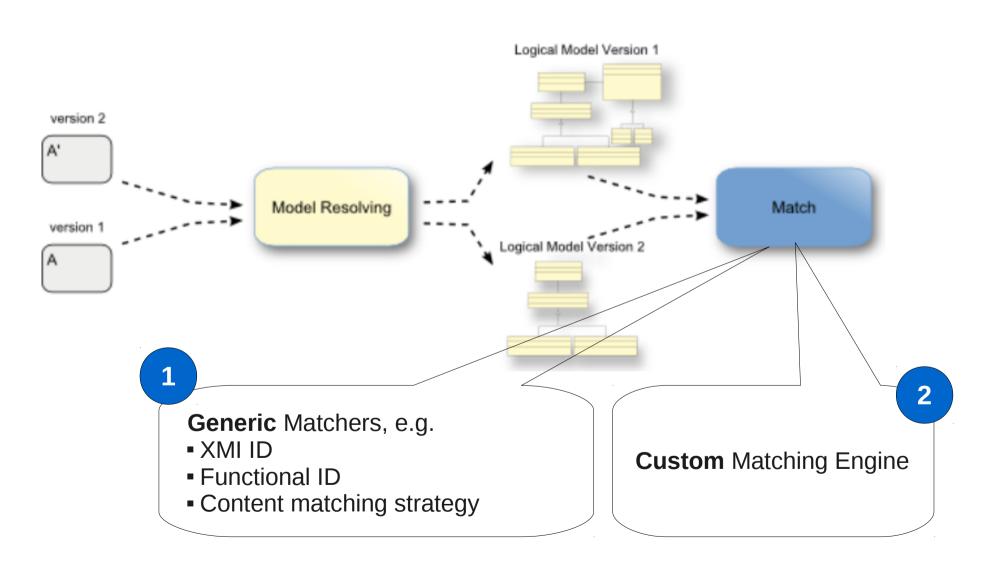
Basic challenge: Model comparison



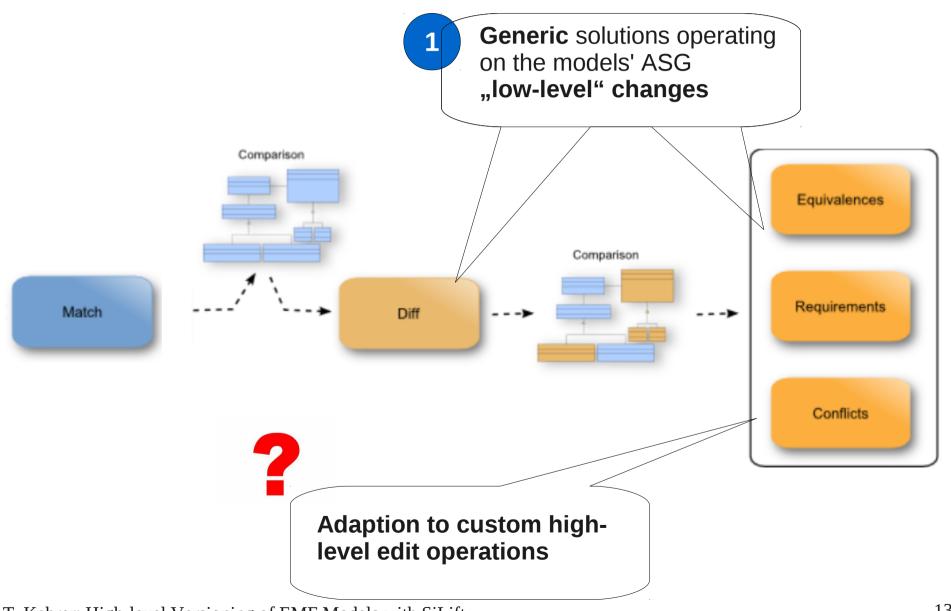
What textual difference tools report...



The processing pipeline of **EMF Compare**Part 1: Matching



The processing pipeline of EMF Compare Part 2: Differencing



Outline

Introduction

The SiLift Approach

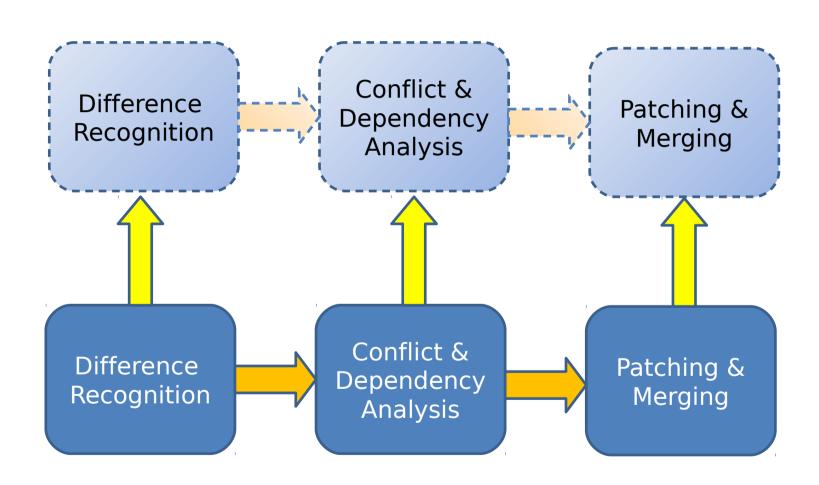
End-user Tool Environment

Summary

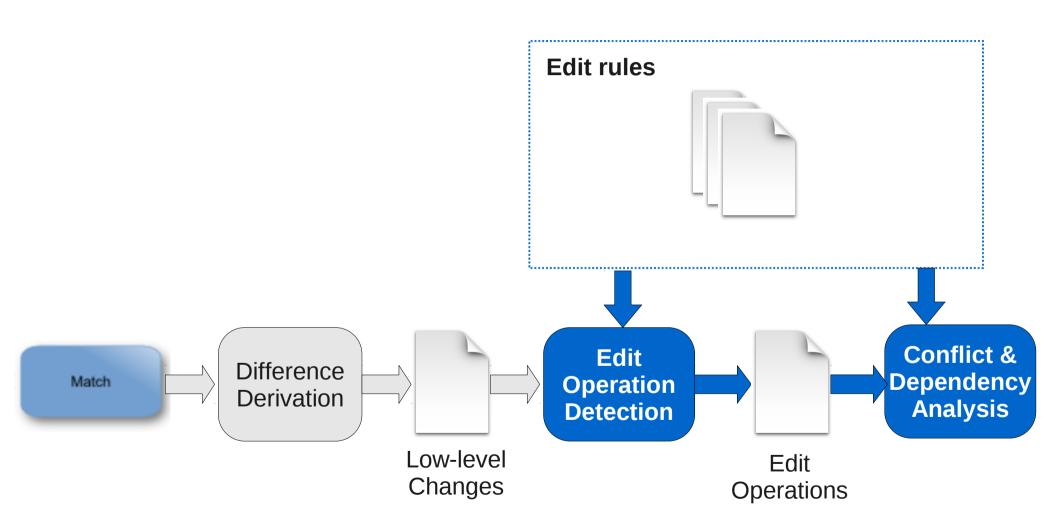
Overall goal: Lift model versioning to the abstraction level of edit operations

High-level changes: Complex editing commands

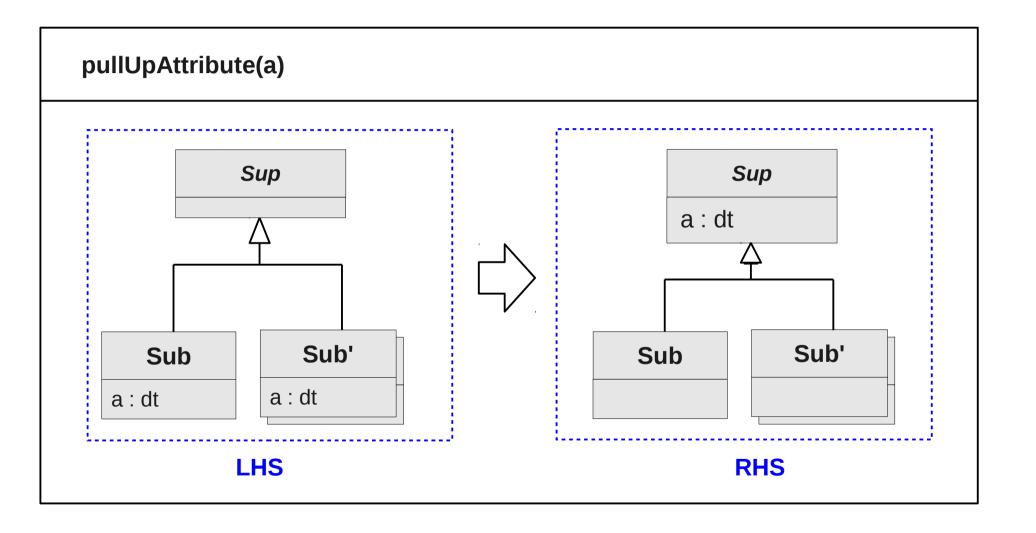
Low-level model changes



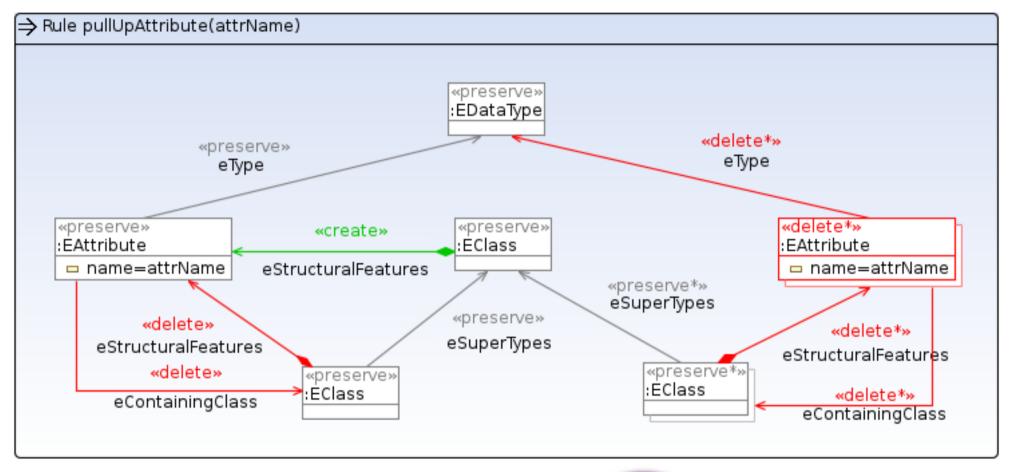
Basic approach



Sample edit rule: "pullUpAttribute" (theoretical foundation)



Sample edit rule: "pullUpAttribute" (implementation in EMF Henshin)





Outline

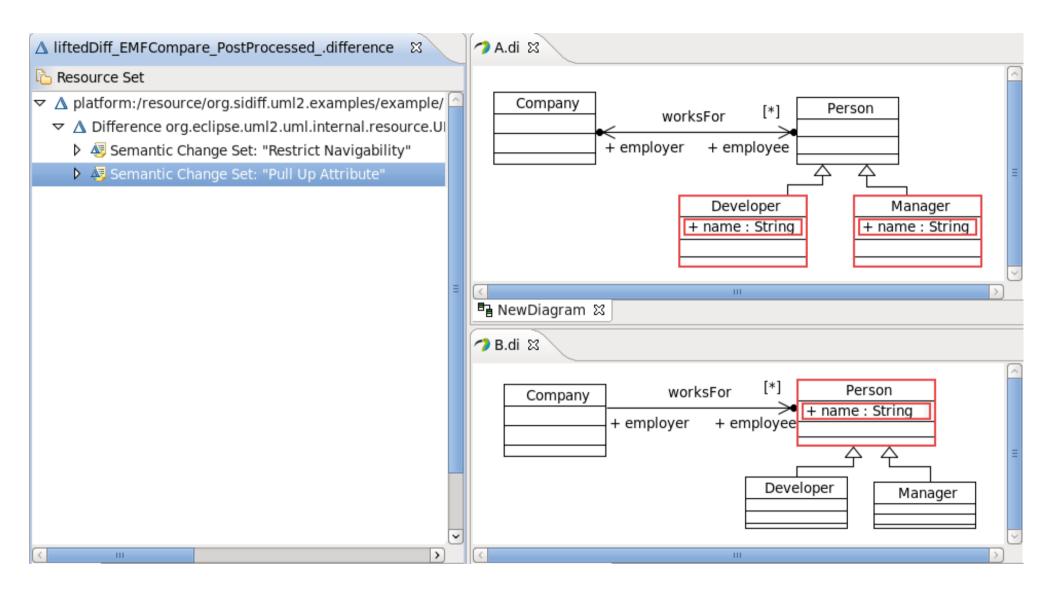
Introduction

The SiLift Approach

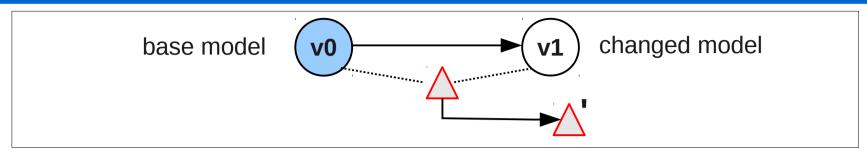
End-user Tool Environment

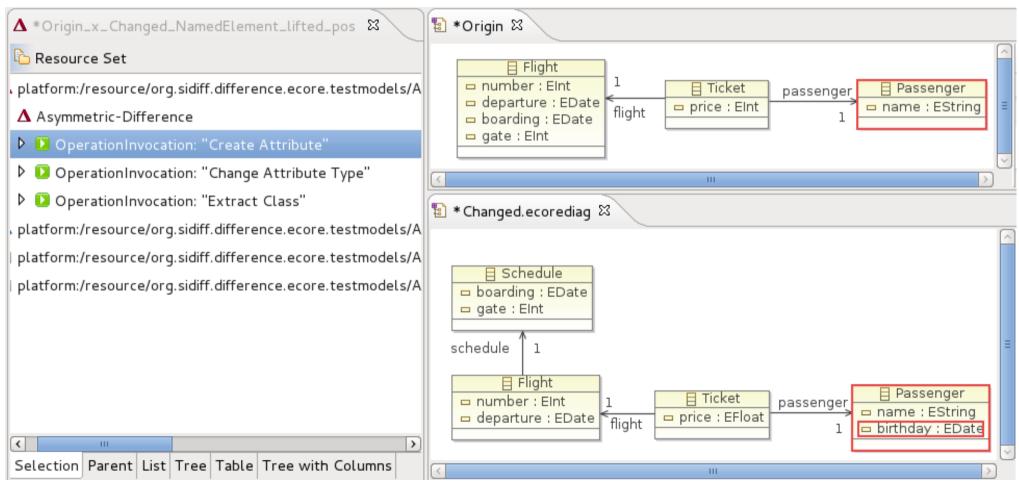
Summary

Difference Viewer

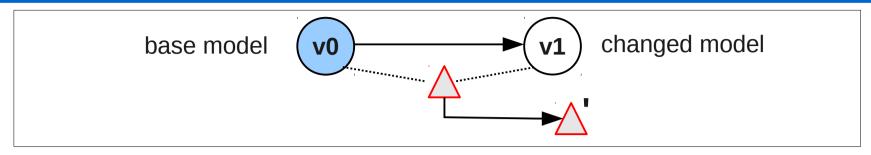


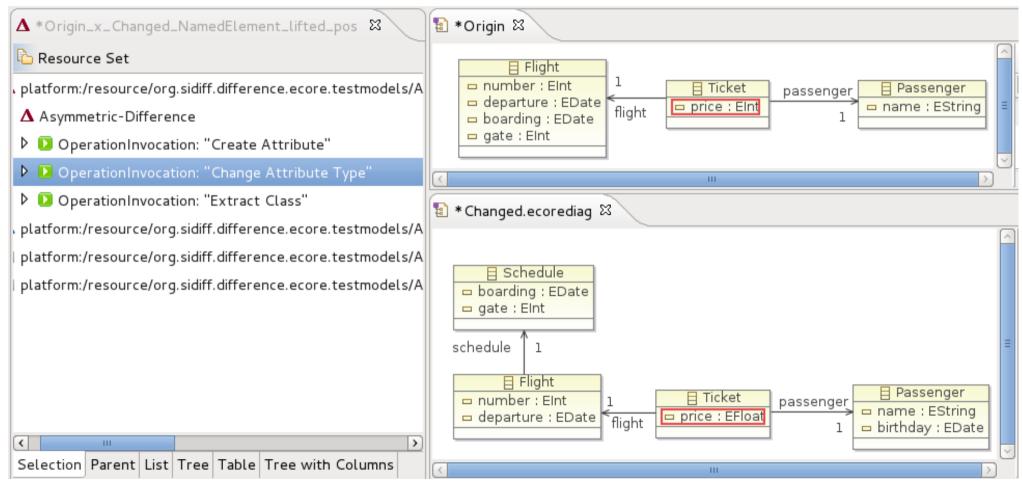
Consistency-preserving editing of patches



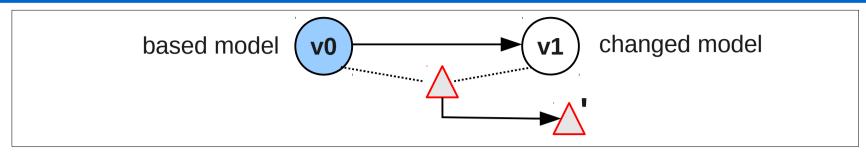


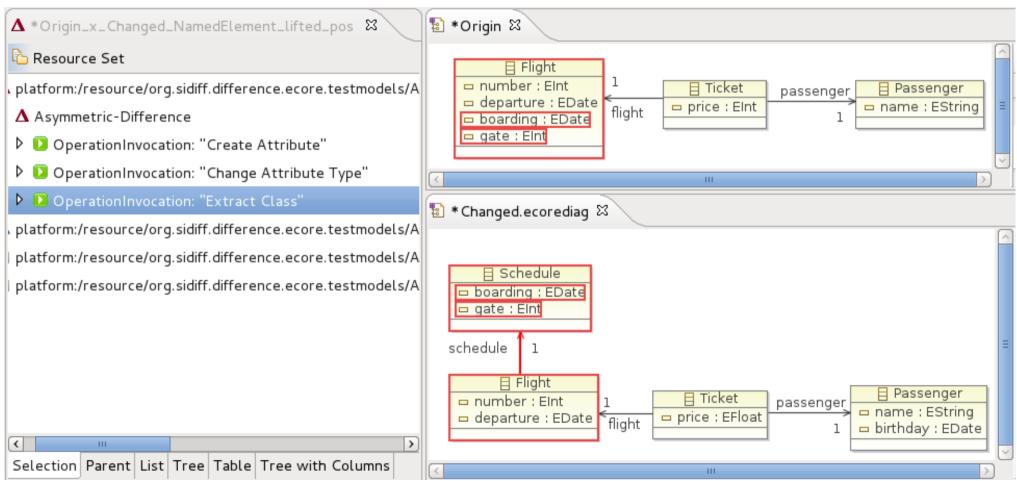
Consistency-preserving editing of patches

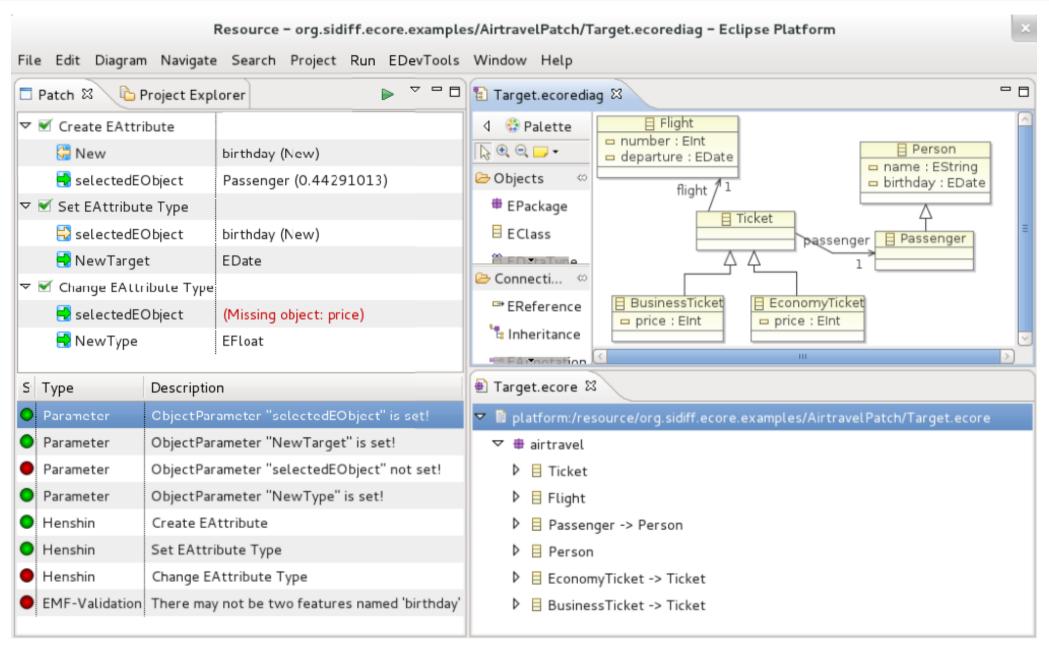


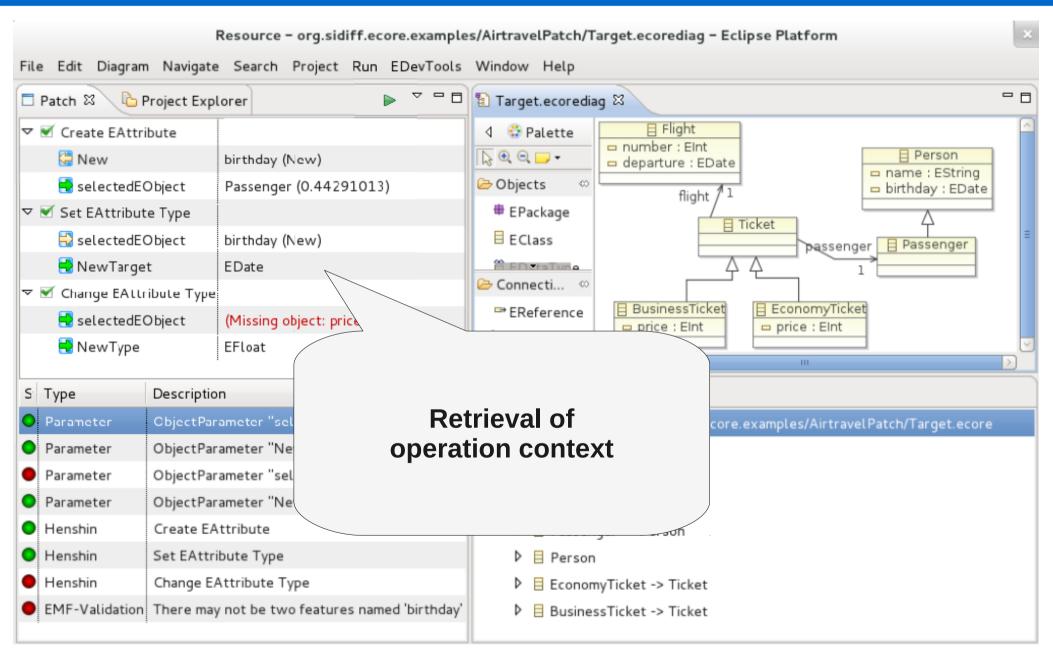


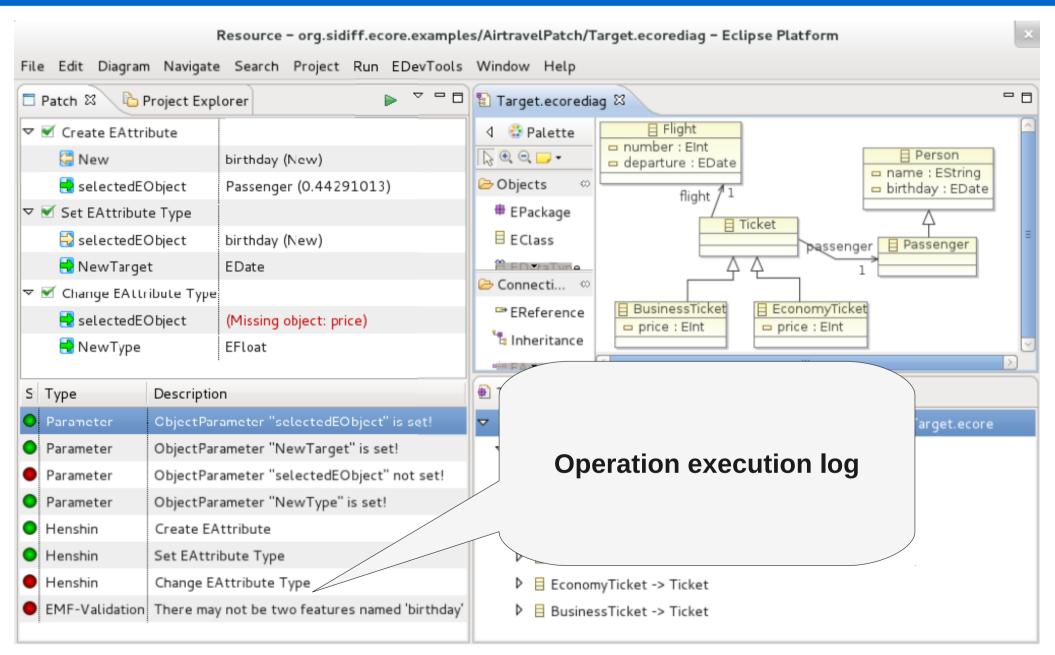
Consistency-preserving editing of patches

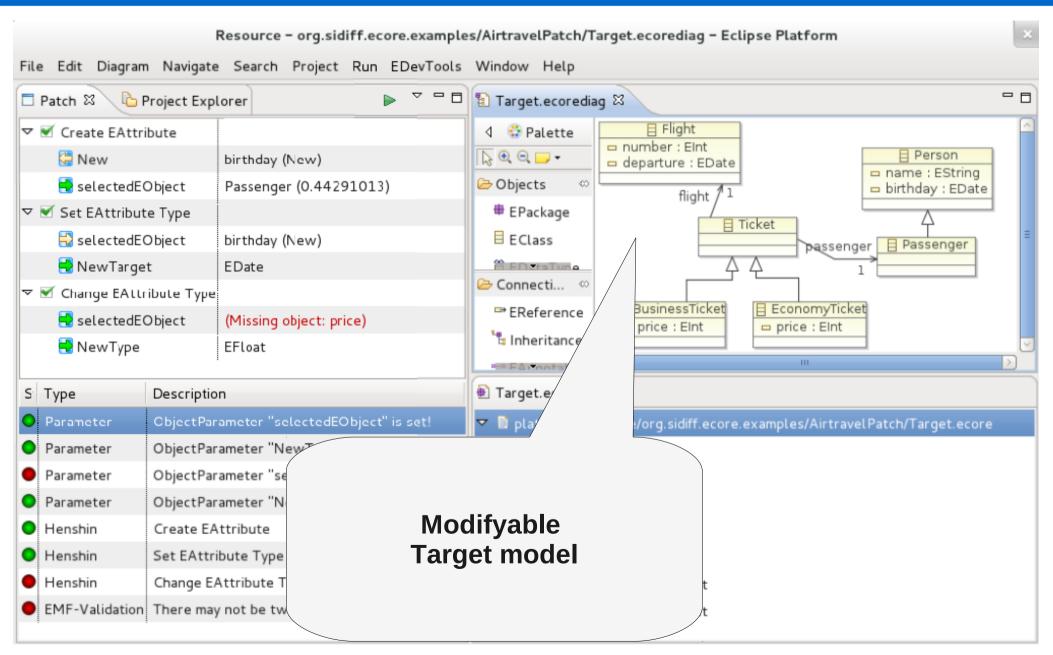


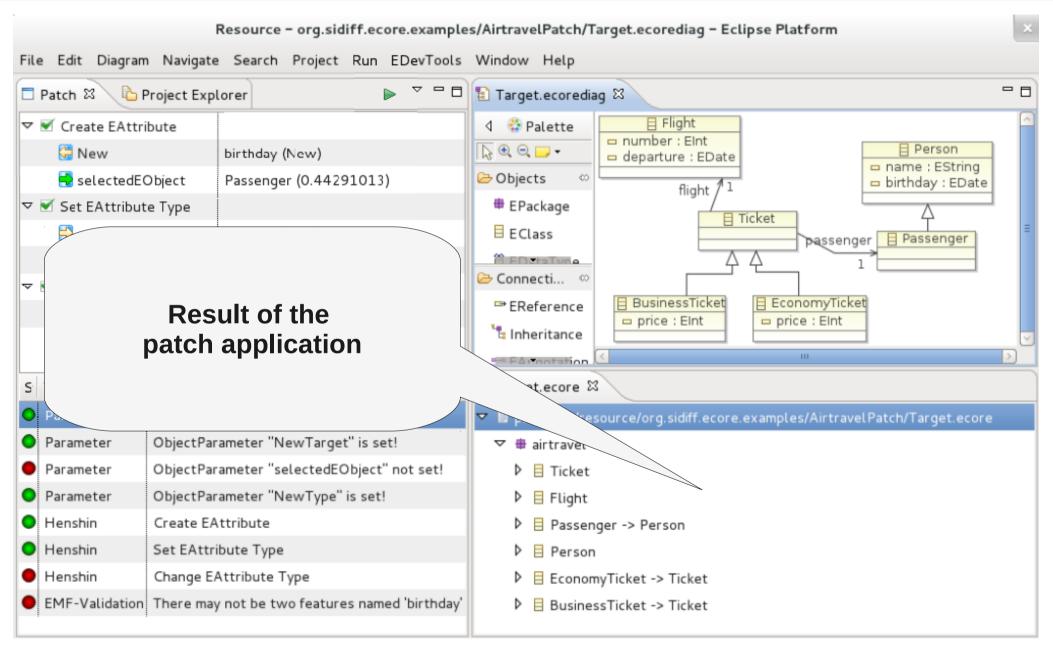












Outline

Introduction

The SiLift Approach

End-user Tool Environment

Summary

Summary

- Unit of change; high-level edit operations
- Formal foundation; graph transformation concepts
- Support for complex edit operations
- High-level conflict and dependency detection
- Consistency-preserving patching

Further information

- SiLift project web site:
 http://pi.informatik.uni-siegen.de/Projekte/SiLift
- Timo Kehrer, Pit Pietsch, Hamed Shariat Yazdi, Udo Kelter. Detection of High-Level Changes in Evolving Java Software. WSR 2013
- Udo Kelter, Timo Kehrer, Dennis Koch. Patchen von Modellen. Software Engineering 2013
- Timo Kehrer, Udo Kelter, Manuel Ohrndorf, Tim Sollbach. Understanding Model Evolution through Semantically Lifting Model Differences with SiLift. ICSM 2012
- Timo Kehrer, Udo Kelter, Gabriele Taentzer. Integrating the Specification and Recognition of Changes in Models. WSR 2012
- Timo Kehrer, Udo Kelter, Gabriele Taentzer. A Rule-Based Approach to the Semantic Lifting of Model Differences in the Context of Model Versioning. ASE 2011